IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
In re the Application of:

Yoichi TAMAKI et al.

Appln. No.:

Filed: Herewith

For: SEMICONDUCTOR DEVICE

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Pursuant to 37 C.F.R. § 1.56, and without any assertion as to materiality or prior art effect, the documents listed on the attached Form PTO-1449 are hereby cited.

Documents AL and AM listed on the attached List are cited in the specification, on pages 1-2, and their relevance is indicated therein.

Respectfully submitted,

MWS: jab

Miles & Stockbridge P.C. 1751 Pinnacle Drive, Suite 500 McLean, Virginia 22102-3833 (703) 903-9000 February 9, 2004 y:_____

itchell W. Shapir

Reg. No. 31,568

FORM PTO-1449					Atty. Docket	No.	Appln	. No.	
LIST OF DOCUMENTS CITED BY APPLICANT					XA-10036				
					Applicant	Applicant			
					Yoichi TAMAKI et al.				
					Filing Date Group				
					Herewith				
				PATENT D	OCUMENTS				
Examiner Initial		Document Number	Date		Name	Class	Sub- class	Filing Date	
	AA						,		
	AB								
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Examiner Initial		Document Number	Date	Co	ountry	Class	Sub- class	Translation	
	AL	10-173040	6/26/98	Japan				Abstract	
	AM	2002-57219	2/22/02	Japan				Abstract	
	AN	2002-299466	10/11/02	Japan				Abstract	
	AO						-		
	AP								
	AQ								
	AR								
	AS								
		OTHER	(including aut	hor, title, d	ate, pertinent p	ages, etc.)	<u>-</u>		
	АТ								
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EXAMINER: 609; draw	v lin	itial if reference through citate to the communication	ion if not i	n conformanc	or not citations or not cons			ce with MPEP	